

**Attorney Docket No:0492611-0545/MIT9277CONII**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Seleznev, *et al*                      Examiner: Wartalowicz, Paul A.  
Serial No.: 10/799,388                              Art Unit: 1793  
Filing Date: March 12, 2004  
Title: VACUUM PROCESSING FOR FABRICATION OF  
          SUPERCONDUCTING THIN FILMS FABRICATED BY METAL-  
          ORGANIC PROCESSING

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Sir:

**TRANSMITTAL**

Enclosed for filing in the above-identified patent application, please find the following documents:

1. Response to Office Action Under 37 C.F.R. § 1.111 (5 pages);
2. Petition for Extension of Time (2 pages); and
3. This Transmittal (1 page).

Please charge any additional fees associated with this filing, or apply any credits, to our Deposit Account No. 03-1721.

Respectfully submitted,

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**Dated: September 4, 2008**